



RECEIVED
NOV 04 2003
TECHNOLOGY CENTER R3700

1762
3753
P/2292-46
11-5-03
#10

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Patent Application of

Byeung-Joon AHN, et al.

Date: October 28, 2003

Serial No.: 09/915,703

Group Art Unit: 1762

Filed: July 26, 2001

Examiner: Ljiljana V. Ciric

For: METHOD FOR FABRICATING SURFACE MOUNTABLE CHIP INDUCTOR

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SUBMISSION

Sir:

Submitted herewith is a copy of art together with a form listing the same for the convenience of the Examiner.

I certify that each item of information contained in this Submission was cited in a communication from a foreign patent office in a counterpart foreign application not more than 3 months prior to the filing of this Submission. An English equivalent or complete translation of the Japanese references was not available in all instances.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to:
Commissioner for Patents P.O. Box 1450,
Alexandria, VA 22313-1450, on October 28, 2003

Respectfully submitted,

Max Moskowitz


Name of applicant, assignee or
Registered Representative

Signature
October 28, 2003

Date of Signature

Max Moskowitz
Registration No.: 30,576
OSTROLENK, FABER, GERB & SOFFEN, LLP
1180 Avenue of the Americas
New York, New York 10036-8403
Telephone: (212) 382-0700

MM:cg
Enclosures

 <p>APPLICANT'S ART CITATION (Use several sheets if necessary)</p>	Application 09/915,703	OFGS File No. P/2292-46	RECEIVED NOV 04 2003 TECHNOLOGY CENTER R3700
	Applicant Byeung-Joon AHN		
	Filing Date July 26, 2001	Group Art Unit 1762	

U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date MM-YYYY	Name	Class	Sub-class	Filing Date If Appropriate
	US-					
	US-					
	US-					
	US-					
	US-					
	US-					
	US-					
	US-					
	US-					
	US-					
	US-					

FOREIGN PATENT DOCUMENTS

	Document Number	Date MM-YYYY	Country	Class	Sub-class	Translation	
						Yes	No
	2000-036414	02-2000	Japan				X
	11-154610	06-1999	Japan				X
	11-121234	04-1999	Japan				X

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

	Office Action issued by Japanese Patent Office on July 31, 2003 in prosecution of
	corresponding Japanese Patent Application No. 2001-231073 (untranslated)
	English translation of Abstract for Japanese Patent No. 2000-036414
	English translation of Abstract for Japanese Patent No. 11-154610
	English translation of Abstract for Japanese Patent No. 11-121234

Examiner	Date Considered
----------	-----------------

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

BEST AVAILABLE COPY